## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of	)	Art Unit: 2823
Shunpei YAMAZAKI et al.	)	Examiner: Fernando L. Toledo
Serial No. 09/352,194	)	
Filed: July 13, 1999	)	RECEIVED
For: CRYSTALLINE SEMICONDUCTOR TH	IIN)	JUL 1 4 2004
FILM, METHOD OF FABRICATING THE	)	OFFICE OF PETTIONS
SAME, SEMICONDUCTOR DEVICE, AND	)	
METHOD OF FARRICATING THE SAME	)	

## PETITION TO WITHDRAW FROM ISSUE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicant hereby petitions that the subject application be withdrawn from issue to permit consideration of an Information Disclosure Statement under 37 CFR 1.97 (submitted herewith) and a Request for Continued Examination (RCE) (also submitted herewith).

Also submitted herewith is the requisite fee of \$130.00 set forth in 37 CFR 1.17(i).

In view of the foregoing, it is urged that this petition is in order and, accordingly, a prompt grant thereof is requested.

The Commissioner is hereby authorized to charge any fees which may be further required in this application, except the issue fee, or credit any overpayment to Deposit

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Application No. 09/352,194 Docket No. 0756-1998

Account No. 50-2280, under the above order number. A <u>duplicate</u> of this sheet is attached.

Respectfully submitted,

Eric J. Robinson

Reg. No. 38,285

Robinson Intellectual Property Law Office PMB 955 21010 Southbank Street Potomac Falls, Virginia 20165 (571) 434-6789 (Voice) (571) 434-9499 (Facsimile)